

REVIEW

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Silicon compounds as stoichiometric coupling reagents for direct amidation

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Despite being one of the most frequently carried out chemical reactions in industry, there is currently no amidation protocol that is regarded as safe, high yielding, environmentally friendly and inexpensive. The direct amidation of a carboxylic acid with an amine is viewed as an inherently good solution for developing such a protocol. Since the 1960s, there has been a gradual development in the use of silicon reagents for direct amidation. This review covers the methods published to April 2021 for silicon reagent mediated direct amidation of a carboxylic acid with an amine. This review also covers the use of polymeric SiO₂ to promote direct amidation.

1. Introduction

The ubiquity of amide bonds cannot be overestimated.¹ Their key role in the function of life, along with the estimation that amide bond formation accounts for 25% of all reactions carried out in drug discovery and development,² makes amides one of the most important functional groups known to chemists. Accordingly many efficient and inventive protocols have been developed to form this bond that have been reviewed many times.^{3–10} Notwithstanding this state of affairs, it is surprising that amidation is still a reaction considered non-ideal, as outlined by the 2007 ACS Green Chemistry Institute (GCI) Pharmaceutical Roundtable, which voted that an aim to develop amide formation avoiding poor atom economy reagents should be the top priority for the chemical research community.¹¹ In 2018, the ACS GCI Pharmaceutical Roundtable redefined the goal to develop general methods for catalytic/sustainable (direct) amide or peptide formation, reflecting the unsolved nature of sustainable amidation.¹² Accordingly, much current interest is directed at the development of direct amidations of carboxylic acids with amines.^{13–17}

A further challenge to amidation, other than the environmental impact, is scope, where the ease of direct amidation between various carboxylic acids and amines varies considerably. Ideally, a given amidation protocol, whether catalytic or stoichiometric, should be applicable to couple a wide variety of acid and amine substrates.

Over the past 50 years, various silicon reagents have been reported for direct amidations. This review summarises these

protocols in terms of scope – including peptide bond formation. Heterogeneous silicon protocols utilizing silica as a catalyst for direct amidation, are also described. The coupling reagents are grouped according to the leaving group at silicon, starting with those with Si–Cl bonds as these were the first type to be developed for amidation, and progressing through those with Si–H, Si–N and Si–O bonds. In the case of HSi(OCH(CF₃)₂)₃ with two different reactive Si–X bonds it is grouped with the silanes on the basis of its reactivity. A table of comparison of the reagents (including hazards) is also presented in the review with the aim of being a quick referral tool for the reader.

2. Reagents with Si–Cl bonds

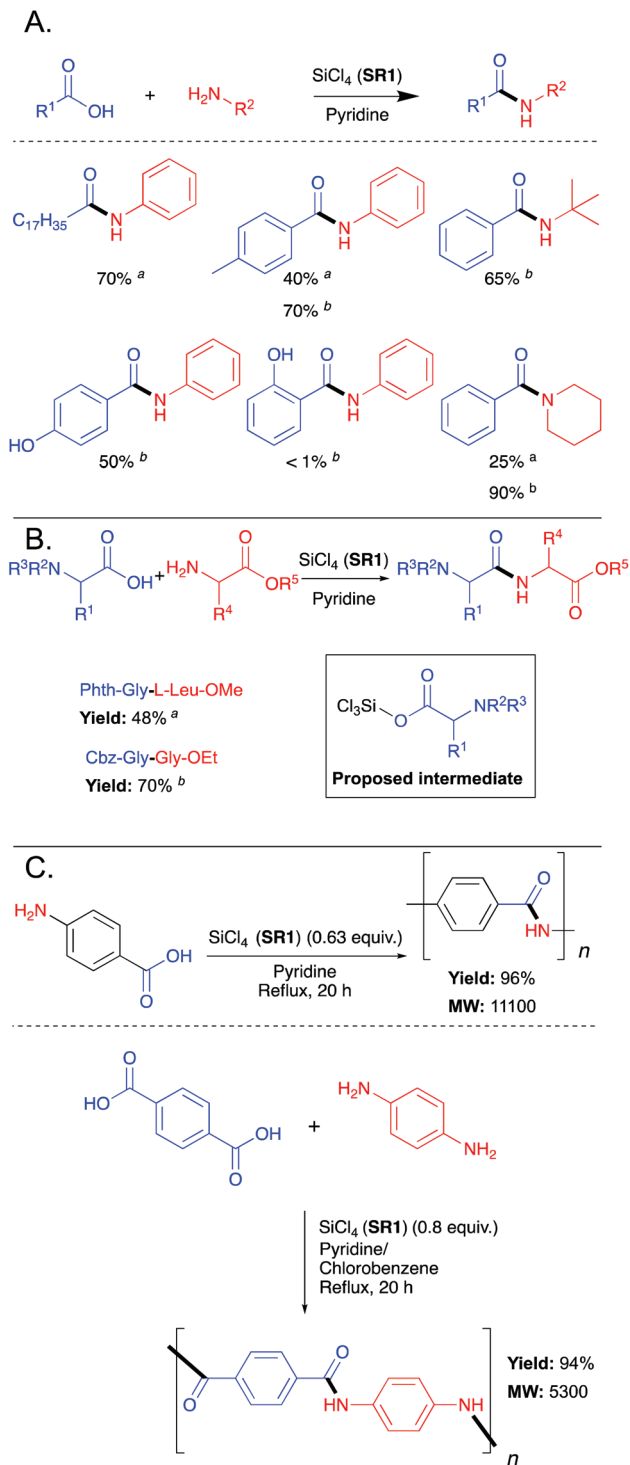
2.1. Tetrachlorosilane

The first reported use of a stoichiometric silicon-based reagent (SR) for direct amidation of a carboxylic acid with an amine was in 1969.¹⁸ Chan *et al.* demonstrated that the use of silicon tetrachloride (SR1) as the reagent in pyridine as the solvent (and also as an acid scavenger) provided amide products (Scheme 1A). A key benefit of this protocol is that the chlorosilane SR1 is destroyed in the work-up and converted into silica, which is easily removed.

In 1971, Chan *et al.* attempted to expand the scope of this method by applying it to the synthesis of dipeptides.¹⁹ However, initial attempts to couple an *N*-protected amino acid directly with an amino ester failed, where the *N*-protected amino acid was completely recovered while the amino ester underwent polymerisation. Chan *et al.* proposed that a silyl ester would be the reactive intermediate and could be formed *in situ* by initial addition of the *N*-protected amino acid followed by the addition of the amino ester, thus preventing

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Scheme 1 (A) Selected examples of SiCl_4 (SR1) mediated amide bond formation.¹⁸ Reaction conditions: ^a25 °C, 10 h; ^breflux, 1 h. (B) Selected examples of SiCl_4 mediated formation of dipeptides.¹⁹ Reaction conditions: ^a110 °C, 30 min; ^b60 °C, 85 min. (C) SiCl_4 mediated polymerisations.²⁰ See Table 1, entry 1 for full substrate scope.

undesirable polymerisation. Accordingly, a series of dipeptides (Scheme 1B) were made by allowing *N*-protected amino acids to react with SiCl_4 prior to addition of an amino ester.¹⁹ It was

noted that tetrabenzoyloxy silane was a by-product with Cbz protected compounds but that other protecting groups such as phthaloyl (Phth), benzoyl (Bz) and acetyl (Ac) were tolerated. Significant racemisation was found by analysing the optical rotation of the peptide products. From the reaction of Bz-L-Leu with Gly-OEt, the optically inactive 4-isobutyl-2-phenyloxazone was isolated and was proposed as the mode of racemisation.

In 1985, Heitz *et al.* showed that aromatic polyamides could be prepared *via* direct amidation polycondensation reactions mediated by tetrachlorosilane (SR1), and to date these constitute the only reported examples utilizing a silicon-based reagent for polyamide formation (Scheme 1C).²⁰

2.2. Alkylchlorosilanes

In 2002, Leeuwen *et al.* demonstrated that dimethyl-dichlorosilane (SR2) could be utilised in a simultaneous protection-activation strategy for the direct amidation of unprotected amino acids through the presumed intermediacy of a cyclic silane (Scheme 2A).²¹ Pyridine was again employed as the solvent and as an acid scavenger, and the use of primary amines with the amino group attached to a primary carbon atom were required for good yield. This dichlorodialkylsilane-mediated amidation strategy was also applicable to *N*-alkylamino acids, β -amino acids and also for the regio-selective direct amidation of aspartic acid (Scheme 2B). In 2015 Fedorov *et al.* extended the scope to include 2° cyclic amines as nucleophiles.²²

2.3. Arylchlorosilanes

In 2016, Charette *et al.* reported conformationally flat and rigid 9-silafluorenyl dichlorides (SR5–SR10) (Scheme 2D) as superior reagents to phenyltrichlorosilane (SR4) for the direct amidation of *N*-Boc protected amino acids with amino esters (Scheme 2C).²³ Notably, no epimerisation was observed in these amidations, and the method could be extended to the formation of tripeptides. A ligation mechanism is proposed. Charette *et al.* provided experimental evidence for the mechanism of their protocol, with a computational study being carried out by Jiang *et al.*²⁴ The coupling competency of SR7 was demonstrated over range of different amino acid substrates.

3. Reagents with Si–H bonds

3.1. Phenylsilane

In 2006, Ruan *et al.* were the first to demonstrate the use of PhSiH_3 (SR11) as a coupling reagent for direct amide bond formation (Scheme 3A).²⁵ This protocol was also successful for the synthesis of solid supported amides (Scheme 3B).

In 2020 Blanchet *et al.* re-examined the use of PhSiH_3 (SR11) and confirmed its utility for the formation of amides when using acetonitrile as the reaction solvent.²⁶ In contrast to



Table 1 Comparison of substrate scope, cost and hazard codes for stoichiometric silicon reagents

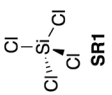
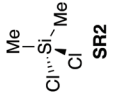
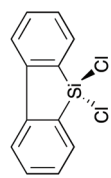
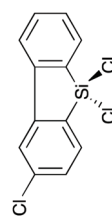
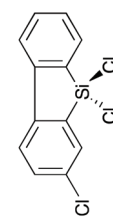
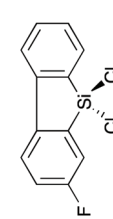
Entry	Silicon reagent	Presynthesis required?	Acid : amine : silicon ratio [solvent]	Aliphatic carboxylic acid+				Aromatic Carboxylic acid+				Aniline+		Price ^a	Hazard statement ^b
				1° amine	Cyclic 2° amine	Acyclic 2° amine	1° amine	Cyclic 2° amine	Acyclic 2° amine	1° amine	Cyclic 2° amine	RCO ₂ H	ArCO ₂ H		
1 ^{18,19}		NO	1.0 : 1.0 : 0.75 [Pyridine]	ND	ND	ND	60% (25 °C)	90% (115 °C)	ND	70% (115 °C)	70% (115 °C)	Range of amino acids (protected) (60 °C – reflux)	Range of amino acids (protected) (rt)	£0.11 per g	H301, H314, H315, H335
2 ^{21,22}		NO	1.0 : 1.1 : 3.0 [Pyridine]	ND	ND	ND	ND	ND	ND	ND	ND	Range of amino acids (unprotected) (rt)	Range of amino acids (unprotected) (rt)	£0.06 per mL	H225, H302, H314, H331
3 ²³	MePhSiCl ₂ SR3	NO	1.1 : 1.1 : 1.0 + additive [THF]	26% (rt –60 °C)	ND	ND	ND	ND	ND	ND	ND	ND	ND	£0.62 per mL	H314
4 ²³	Ph ₂ SiCl ₂ SR4	NO	1.1 : 1.1 : 1.0 + additive [THF]	75% (rt –60 °C)	ND	ND	ND	ND	ND	ND	ND	ND	ND	£0.69 per mL	H310, H314
5 ²³		YES	1.1 : 1.1 : 1.0 + additives [THF]	99% (rt –60 °C)	96% (rt –60 °C)	84% (rt –60 °C)	ND	96% (rt –60 °C)	ND	ND	ND	Range of amino acids (protected) (rt –60 °C)	Range of amino acids (protected) (rt –60 °C)	NA	NA
6 ²³		YES	1.1 : 1.1 : 1.0 + additives [THF]	ND	ND	ND	ND	ND	ND	ND	ND	Small range of amino acids (protected) (rt –60 °C)	Small range of amino acids (protected) (rt –60 °C)	NA	NA
7 ²³		YES	1.1 : 1.1 : 1.0 + additives [THF]	ND	ND	ND	ND	ND	ND	ND	ND	Range of amino acids (protected) (rt –60 °C)	Range of amino acids (protected) (rt –60 °C)	NA	NA
8 ²³		YES	1.1 : 1.1 : 1.0 + additives [THF]	ND	ND	ND	ND	ND	ND	ND	ND	Small range of amino acids (protected) (rt –60 °C)	Small range of amino acids (protected) (rt –60 °C)	NA	NA





Table 1 (Contd.)

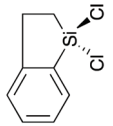
Entry	Silicon reagent	Presynthesis required?	Acid : amine : silicon ratio [solvent]	Aliphatic carboxylic acid+			Aromatic Carboxylic acid+			Aniline+		Price ^a	Hazard statement ^b
				1° amine	Cyclic 2° amine	Acyclic 2° amine	1° amine	Cyclic 2° amine	Acyclic 2° amine	RCO ₂ H	ArCO ₂ H		
9 ²³		YES	1.1 : 1.1 : 1.0 + additives [THF]	ND	ND	ND	ND	ND	ND	ND	ND	Small range of amino acids (protected) (rt –60 °C)	NA
10 ²³		YES	1.1 : 1.1 : 1.0 + additives [THF]	ND	ND	ND	ND	ND	ND	ND	ND	Small Range of amino acids (protected) (rt –60 °C)	NA
11 ²⁵		NO	1.0 : 1.0 : 3.0 [DMF]	88% (rt)	89% (rt)	94% (rt)	85% (rt)	98% (rt)	0% (rt)	ND	0% (rt)	Limited range (protected)	H225, H302, H332, H315, H319, H335
12 ²⁶			1.0 : 1.0 : 1.5 [MeCN/CH ₂ Cl ₂]	ND	99% (20 °C)	Weinreb amide – 74% (20 °C)	ND	93% (20 °C)	Weinreb amide – 86% (20 °C)	61% (20 °C)	ND	Range of amino acids (protected)	£5.16 per g
13 ³¹		NO	1.0 : 1.0 : 1.0 [MeCN] (some require additives)	80% (80 °C)	88% (80 °C)	94% (80 °C)	74% (80 °C)	67% (80 °C)	ND (80 °C)	46% (80 °C)	ND	Range of amino acid (protected) (+additives)	£3.01 per g
14 ³³			1.0 : 1.0 : 1.0 + additives [MeCN]	91% (100 °C)	98% (100 °C)	53% (100 °C)	87% (100 °C)	ND	ND	28% (100 °C)	ND	Single example (protected amino acid) (100 °C)	£3.01 per g
15 ³¹	Me ₃ PhSiH SR13	NO	1.0 : 1.0 : 1.0 [MeCN] (80 °C)	32% (80 °C)	ND	ND	ND	ND	ND	ND	ND	ND	£2.04 per g
16 ³¹	Ph ₃ SiH SR14	NO	1.0 : 1.0 : 1.0 [MeCN] (80 °C)	50% (80 °C)	ND	ND	ND	ND	ND	ND	ND	ND	£2.18 per g
17 ³¹	Et ₂ SiH ₂ SR15	NO	1.0 : 1.0 : 1.0 [MeCN] (80 °C)	14% (80 °C)	ND	ND	ND	ND	ND	ND	ND	ND	£8.12 per mL
													H226, H318
													H315, H319
													H225

Table 1 (Contd.)

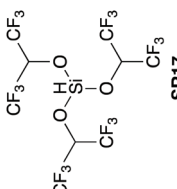
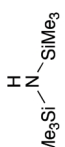
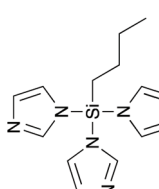
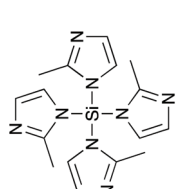
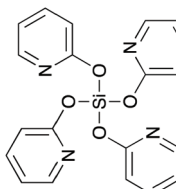
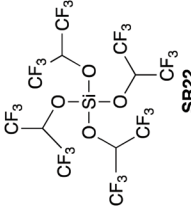
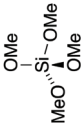
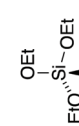
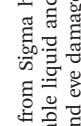
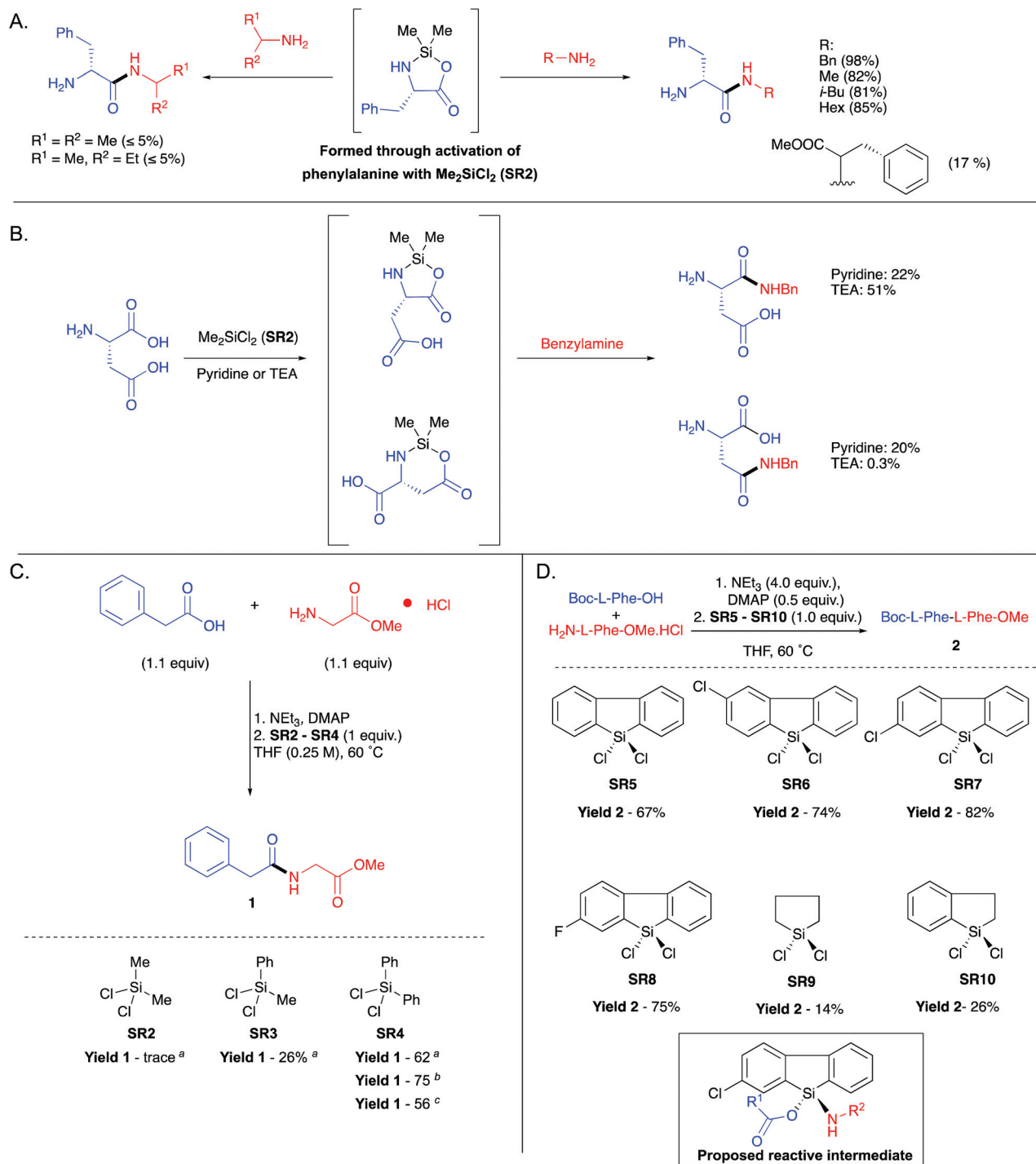
Entry	Silicon reagent	Presynthesis required?	Acid : amine : silicon ratio [solvent]	Aliphatic carboxylic acid+			Aromatic Carboxylic acid+			Aniline+		Price ^a	Hazard statement ^b
				1° amine	Cyclic 2° amine	Acyclic 2° amine	1° amine	Cyclic 2° amine	Acyclic 2° amine	RCO ₂ H	ArCO ₂ H		
18 ³¹	MePhSiH ₂ SR16	NO	1.0 : 1.0 : 1.0 [MeCN]	76% (80 °C)	ND	ND	ND	ND	ND	ND	ND	£5.52 per mL	H226, H315, H319, H335
19 ^{35,36}	 SR17	YES	1.0 : 1.0 : 1.0 (with catalyst) CH ₂ Cl ₂	>99% (with catalyst) (rt)	ND	ND	96% (with catalyst) (rt)	ND	ND	ND	ND	NA	NA
20 ³⁹	 SR18	NO	1.0 : 1.0 : 1.0/2.0 [No solvent]	85% (110 °C)	83% (110 °C)	ND	ND	83% (110 °C)	ND	ND	ND	£0.14 per mL	H225, H302, H332, H311, H412
21 ⁴⁰	 SR19	YES	1.0 : 1.2 : 1.2 [THF]	88% (rt)	96% (rt)	96% (rt)	71% (rt)	82% (rt)	ND	53% (50 °C)	ND	NA	NA
22 ⁴⁰	 SR20	YES	1.0 : 1.2 : 0.6 [THF]	90% (rt)	96% (rt)	92% (rt)	76% (rt)	87% (rt)	ND	71% (50 °C)	ND	NA	NA
23 ⁴¹	 SR21	YES	1.2 : 1.0 : 0.6 [THF]	98% (rt)	97% (rt)	93% (rt)	84% (rt)	85% (rt)	ND	86% (rt)	ND	NA	NA



Table 1 (Contd.)

Entry	Silicon reagent	Presynthesis required?	Acid : amine : silicon ratio [solvent]	Aliphatic carboxylic acid+			Aromatic Carboxylic acid+			Aniline+		Price ^a	Hazard statement ^b
				1° amine	Cyclic 2° amine	Acyclic 2° amine	1° amine	Cyclic 2° amine	Acyclic 2° amine	RCO ₂ H	ArCO ₂ H		
24 ⁴²		YES	1.0 : 1.2 : 1.0 [THF]	92% (rt)	92% (rt)	83% (rt)	72% (rt)	ND	ND	97% (rt – 50 °C)	81% (rt)	NA	NA
25 ⁴⁴		NO	1.0 : 1.0 : 2.0 [Toluene]	100% (reflux)	98% (reflux)	81% (reflux)	98% (reflux)	98% (reflux)	88% (reflux)	84% (reflux)	100% (reflux)	£0.34 per g	H226, H315, H318, H330
26 ⁴³		NO	1.0 : 1.0 : 1.0 [MeCN]	22% (110 °C)	ND	ND	ND	ND	ND	ND	ND	ND	ND
27 ⁴²		NO	1.0 : 1.2 : 1.0 [THF]	9% (rt)	ND	ND	ND	ND	ND	ND	ND	ND	ND
28 ⁴²		NO	1.0 : 1.2 : 1.0 [THF]	8% (rt)	ND	ND	ND	ND	ND	ND	ND	£0.08 per mL	H226, H319, H332, H335
29 ⁴⁴		NO	1.0 : 1.0 : 2.0 [Toluene]	85% (110 °C)	ND	ND	ND	ND	ND	ND	ND	ND	ND
30 ⁴²		NO	1.0 : 1.2 : 1.0 [THF]	99% (rt)	ND	69% (rt)	ND	ND	ND	ND	ND	NA	NA
31 ⁴²		NO	1.0 : 1.2 : 1.0 [THF]	99% (rt)	ND	83% (rt)	ND	ND	ND	ND	ND	NA	NA
32 ²⁶		NO	1.0 : 1.0 [THF]	ND	0% (rt)	ND	ND	ND	ND	ND	ND	£4.80 per mL	H314
33 ²⁶		NO	1.0 : 1.0 [THF]	ND	57% (rt)	ND	ND	ND	ND	ND	ND	£1.00 per g	H302, H314
34 ²⁶		NO	1.0 : 1.0 [THF]	99% (rt)	99% (rt)	99% (rt)	ND	ND	ND	ND	ND	£1.89 per g	H314

^a Prices from Sigma <https://www.sigmaaldrich.com/united-kingdom.html> (accessed 11/05/2021) based on the largest available pack size. ^b H225 – Highly flammable liquid and vapour; H226 – Flammable liquid and vapor; H301 – Toxic if swallowed or if inhaled; H302 – Harmful if swallowed; H310 – Fatal if contact with skin; H311 – Toxic if inhaled; H314 – Causes severe skin burns and eye damage; H315 – Causes skin irritation; H318 – Causes serious eye damage; H319 – Causes serious eye irritation; H330 – Fatal if inhaled; H331 – Toxic if inhaled; H332 – Harmful if swallowed or if inhaled; H335 – May cause respiratory irritation; H412 – Harmful to aquatic life with long lasting effect.



Scheme 2 (A) Selected examples of Me_2SiCl_2 (SR2) mediated amide formation.²¹ See Table 1, entry 2 for full substrate scope. (B) Regioselective direct amidation of aspartic acid with Me_2SiCl_2 . (C) Screen of silicon chloride reagents SR2–SR4 for the formation of 1; ^a5 equivalents of NEt_3 ; ^b5 equivalents of NEt_3 and 0.5 equivalents of DMAP; ^c5 equivalents of NEt_3 and 1 equivalent of DMAP.²³ (D) Screen of 9-silafluorenyl and related chlorosilane species SR5–SR10 for optimum amidation protocol. See Table 1, entries 5–10 for full substrate scope.

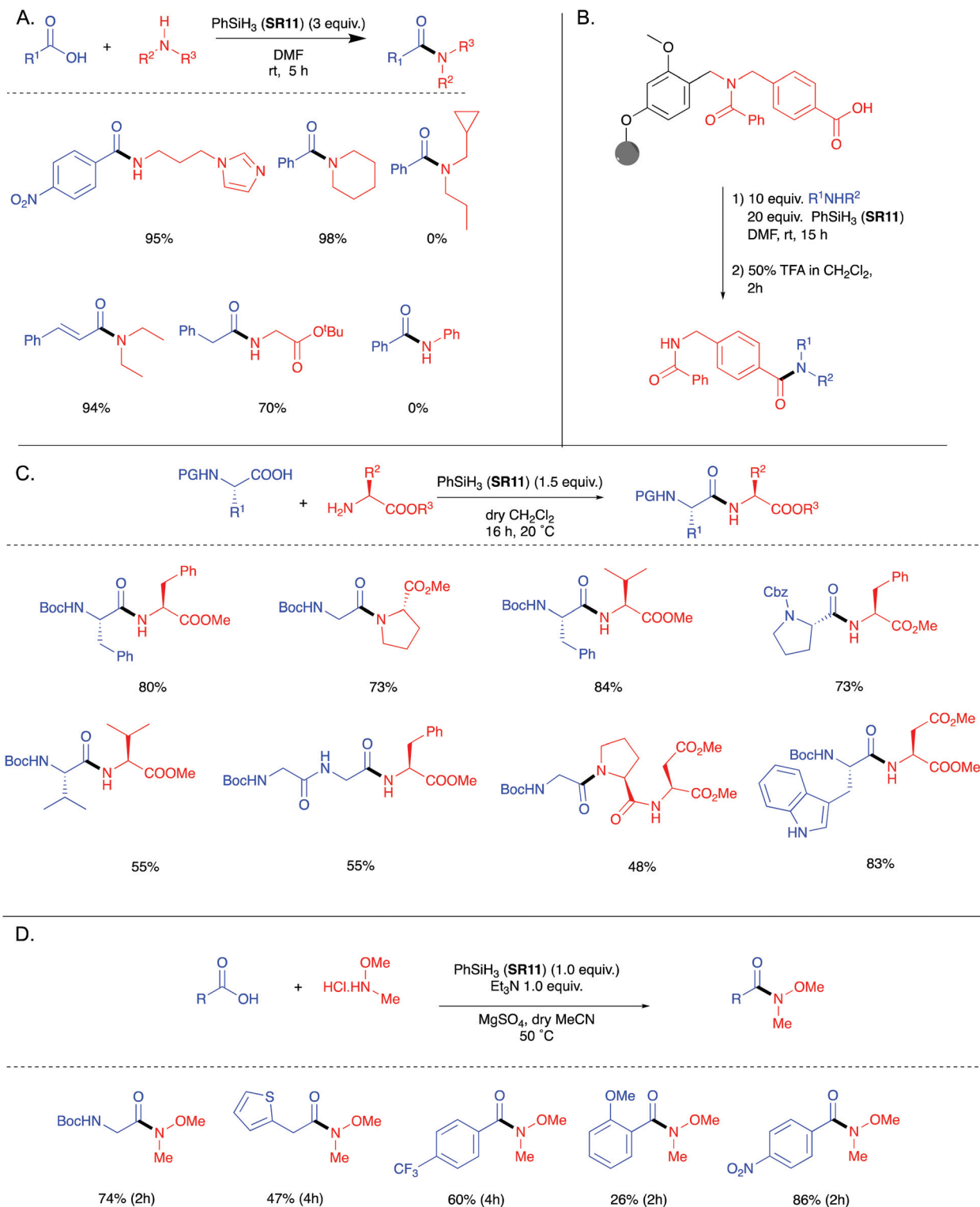
the work by Ruan *et al.* which employed 3 equivalents of silane SR11, it was found that the use of 1.5 equivalents of the silane was optimal.

The scope of this protocol using PhSiH_3 was expanded to form Cbz-, Boc- and Fmoc-protected dipeptides and tripep-

tides without any detectable epimerisation (Scheme 3C). Weinreb amide formation was also reported (Scheme 3D).

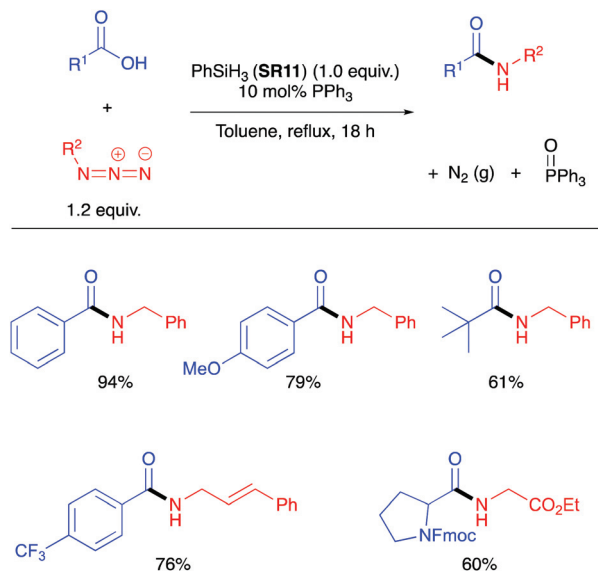
As silanes have precedent²⁷ for the chemoselective reduction of phosphine oxides, a catalytic Staudinger ligation (Scheme 4) was developed in which phenylsilane (SR11) was





Scheme 3 (A) General scheme for PhSiH₃ (SR11) mediated amide bond formation and selected examples showing the scope of the reaction.²⁵ (B) PhSiH₃ mediated amidation and subsequent acid-mediated cleavage of a solid supported acid.²⁵ (C) Selected examples showing the scope of peptide bond formation using PhSiH₃.²⁶ (D) Formation of various Weinreb amides *via* PhSiH₃ mediated amidation.²⁶ See Table 1, entries 11 and 12 for full substrate scope.





Scheme 4 Catalytic Staudinger ligation to form amides with selected examples of scope of the reaction.²⁸

employed as the stoichiometric reductant.²⁸ This catalytic Staudinger ligation was competent for the formation of amides, as well as lactams and peptides, notably without racemisation. Denton demonstrated that the silane cannot be simply regarded as an innocent terminal reductant in these processes,²⁹ and subsequently White and Mecnović provided further mechanistic insight.³⁰

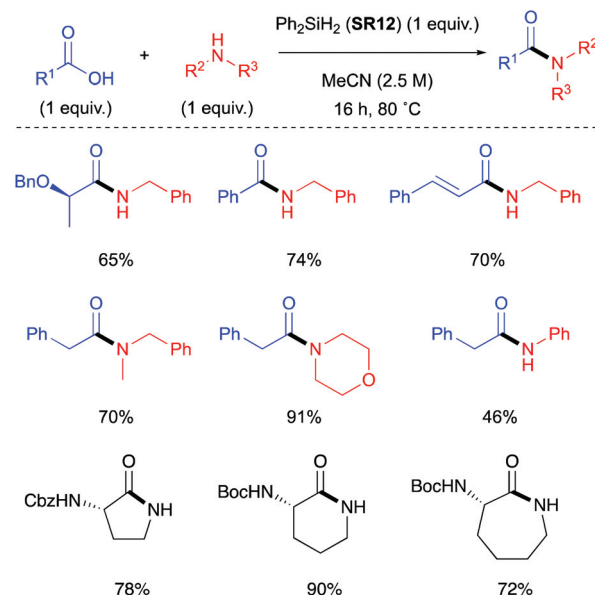
3.2. Diphenylsilane

In 2017, Charette *et al.* reported the use of various aryl and alkyl silanes as reagents for direct amidation, with diphenylsilane (**SR12**) being the most effective under the conditions examined.³¹ Charette found that **SR12** was a superior coupling reagent to Me_2PhSiH (**SR13**), Ph_3SiH (**SR14**), Et_2SiH_2 (**SR15**) and MePhSiH_2 (**SR16**).

Successful direct amidation with **SR12** was demonstrated for various combinations of aromatic and aliphatic carboxylic acids with primary and secondary amines (Scheme 5). Dipeptides, tripeptides and lactam of various ring sizes were also successfully formed. The stoichiometric by-products of these amidations are reported as hydrogen gas and an insoluble siloxane, which facilitates product isolation. Recent computational studies on the system suggest that these reactions proceed *via* nucleophilic attack of the amine on an acyloxysilane formed from the silane and the carboxylic acid with liberation of hydrogen.³² Very recently, Adler *et al.* have reported the beneficial effect of added *N*-methylpyrrolidine for Ph_2SiH_2 mediated direct amidations,³³ as well as a Glorius robustness study for this protocol.³⁴

3.3. $\text{HSi}(\text{OCH}(\text{CF}_3)_2)_3$

In 2020 Muramatsu and Yamamoto published a direct amidation protocol utilizing $\text{HSi}(\text{OCH}(\text{CF}_3)_2)_3$ (**SR17**) as a coup-



Scheme 5 Selected examples of amides and lactams formed using Ph_2SiH_2 (**SR12**) mediated amidation.³¹ See Table 1, entry 13 for full substrate scope.

ling reagent³⁵ for the epimerisation-free formation of dipeptides under ambient conditions (Scheme 6A). As for the other silanes described above, hydrogen gas and a siloxane are generated as the stoichiometric by-products.²⁹ ^{29}Si NMR studies are reported to elucidate the mechanistic course of the reaction (Scheme 6B). The use of catalytic quantities of aminosilane **8** allowed the further development of a high yielding reaction protocol using the ideal 1:1:1 quantities of acid:amine:reagent (Scheme 7). It is important to note that although the protocol has a catalytic aspect, a stoichiometric coupling reagent is still required to promote the bond formation.

Yamamoto *et al.* have since extended their protocol utilizing **SR17** in combination with *N*-(*tert*-butyldimethylsilyl)-*N*-methyltrifluoroacetamide (MTBSTFA) for the one-pot formation of dipeptides between unprotected amino acids.³⁶

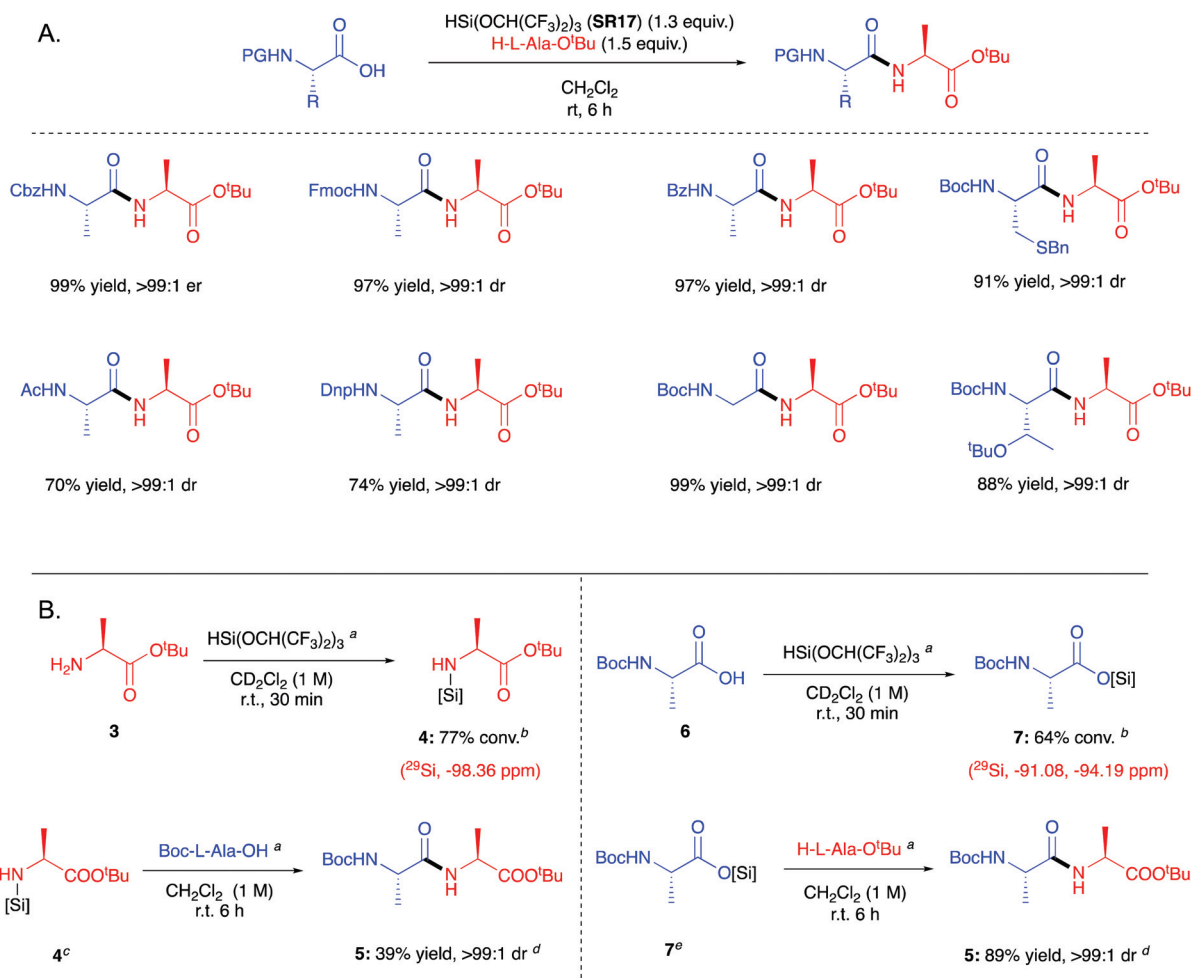
3.4. $(\text{EtO})_2\text{MeSiH}$

In 2014, Mecnović *et al.* reported the use of $(\text{EtO})_2\text{MeSiH}$ as a stoichiometric reducing agent for PPh_3 catalysed direct amidation of unactivated carboxylic acids and amines.³⁷

3.5. Poly(methylhydroxysilane)

In 2017, Mecnović *et al.* published on poly(methylhydroxysilane) as a superstoichiometric reducing agent in an organophosphorus catalysed direct amidation between a carboxylic acid and an amine.³⁸ A silyl ester intermediate was not detected as a reactive intermediate, and it was concluded that the silane's role is purely as a reductant.





Scheme 6 (A) Example of scope of peptides formed with $\text{HSi}(\text{OCH}(\text{CF}_3)_2)_3$ (SR17).³⁵ See Table 1, entry 19 for full substrate scope. (B) Example of mechanistic studies carried out by Yamamoto.³⁵ [Si] = $\text{Si}(\text{OCH}(\text{CF}_3)_2)_3$; ^a1 equivalent added; ^bconversion determined by ¹H NMR spectroscopy; ^c4 was formed *in situ* by reaction of 3 with $\text{HSi}(\text{OCH}(\text{CF}_3)_2)_3$ in CH_2Cl_2 for 1 h (rt); ^ddrs determined by ¹H NMR spectroscopy; ^e7 was formed *in situ* by reaction of 6 with $\text{HSi}(\text{OCH}(\text{CF}_3)_2)_3$ in CH_2Cl_2 for 12 h (rt).³⁵

4. Reagents with Si–N bonds

4.1. Hexamethyldisilazane

In 1999 Chou *et al.* demonstrated that the use of neat HMDS (SR18) coupled carboxylic acids and piperazine (Scheme 8A).³⁹ A base wash and subsequent chromatography resulted in pure amide products. Direct amidation of *N*-Boc-Ala-OH with piperazine was also demonstrated, albeit with partial epimerisation. The intermediacy of a silyl ester was implicated by stepwise heating of an acid with HMDS followed by addition of an amine (Scheme 8B).

4.2. Imidazolesilanes

In 2005, Mukaiyama *et al.* demonstrated that imidazole-1-ylsilanes SR19 and SR20 (Scheme 9) – prepared by trans-silylation of silylchlorides with silylimidazoles – were efficient stoichiometric coupling reagents for direct amidation at ambient temperature.⁴⁰

The work-up protocol post-amidation uses hydrolysis of the silane and subsequent polycondensation to provide an in-

soluble siloxane which could be readily removed by filtration and extraction with EtOAc (this is only applicable to Method B) (Scheme 10).

5. Reagents with Si–O bonds

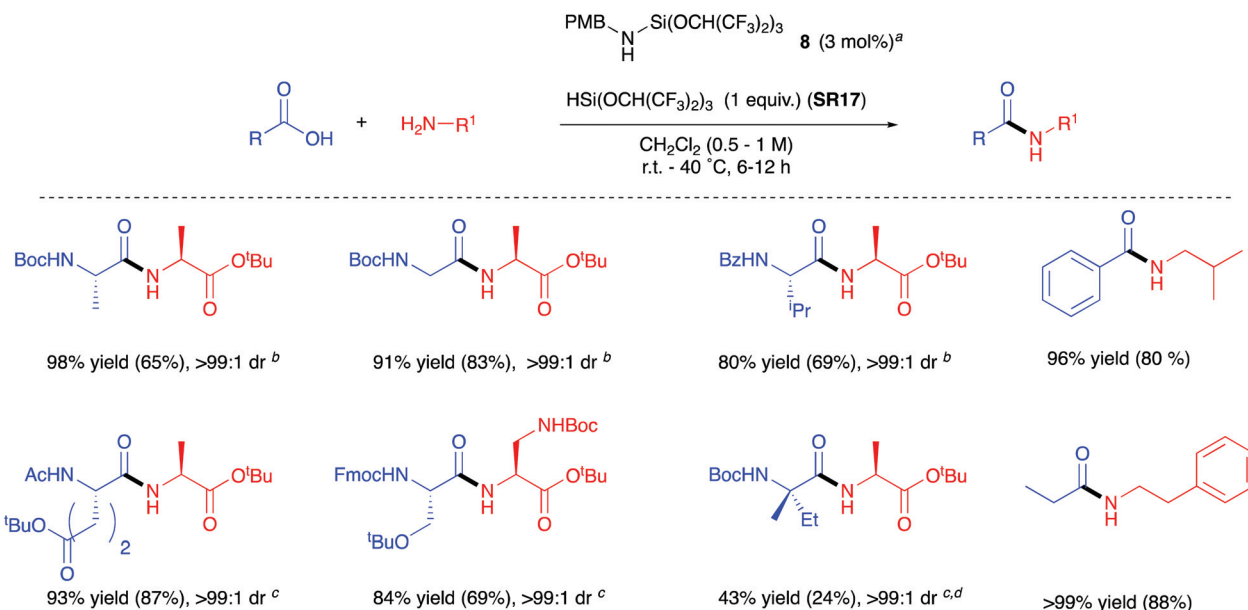
5.1. Tetrakis(pyridine-2-yloxy)silane

In a second report in 2005, Mukaiyama *et al.* demonstrated the use of tetrakis(pyridine-2-yloxy) silane (SR21) as a reagent for direct amidation to give amides in high yield at room temperature.⁴¹ The amides were delivered pure after sequential filtration, and acid–base washes (Scheme 11). As for the synthesis of imidazol-1-ylsilanes,⁴⁰ tetrakis(pyridine-2-yloxy)silane (SR21) was prepared by trans-silylation.

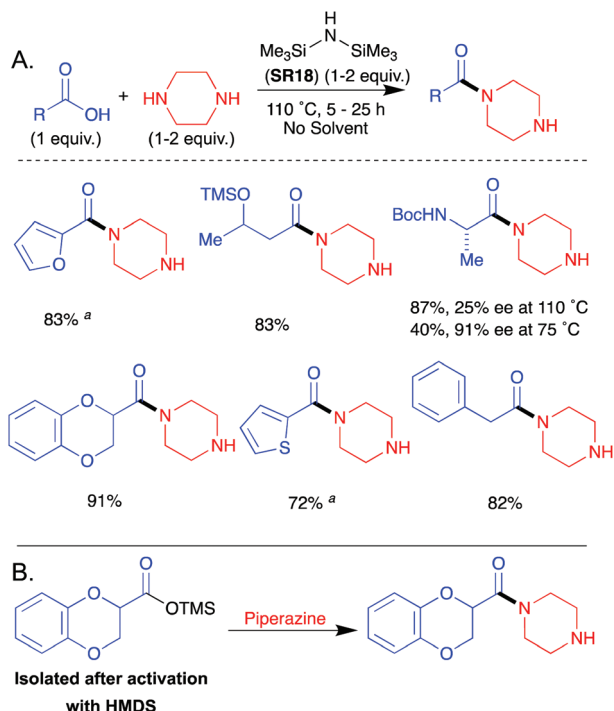
5.2. Tetrakis(1,1,1,3,3,3-hexafluoro-2-propoxy)silane

In a third communication in 2005,⁴² Mukaiyama *et al.* screened (Scheme 12) various alkoxy silanes for their amide



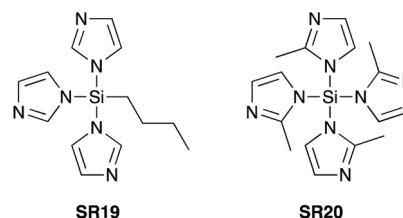


Scheme 7 Scope of dipeptides formed using Yamamoto's catalytic amidation protocol.³⁵ Yield in parenthesis is for when aminosilane catalyst is not added. ^aSilylamine formed *in situ* from silylation of *p*-methoxybenzylamine with $\text{HSi(OCH(CF}_3)_2)_3$ (1 equiv.); ^bdrs provided by HPLC; ^cdrs provided by ¹H NMR spectroscopy; ^d $\text{HSi(OCH}_2\text{CF}_3)_3$ used instead of $\text{HSi(OCH(CF}_3)_2)_3$. See Table 1, entry 19 for full substrate scope.



Scheme 8 (A) Representative scope of $(\text{Me}_3\text{Si})_2\text{NH}$ (**SR18**) mediated amidation reaction.³⁹ ^a5–9% diamide formation was observed. (B) Formation of a silyl ester followed by amide formation. See Table 1, entry 20 for full substrate scope.

coupling abilities, and identified tetrakis(1,1,1,3,3,3-hexafluoro-2-propoxy)silane (**SR22**) as the most competent coupling reagent for direct amide bond formation at room temperature.



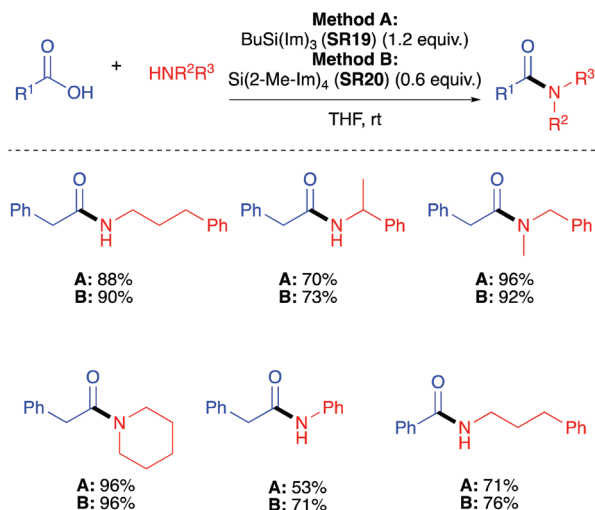
Scheme 9 Silylimidazoles prepared from trimethylsilylimidazole precursors.⁴⁰

The incorporation of fluorine substituents was found to be beneficial compared to alkoxy groups, and the branched nature of the hexafluoroisopropanol grouping prevented competitive ester formation. Pure amides were obtained after a simple acid–base wash regime. The reagent was reported to be prepared in a glove box.

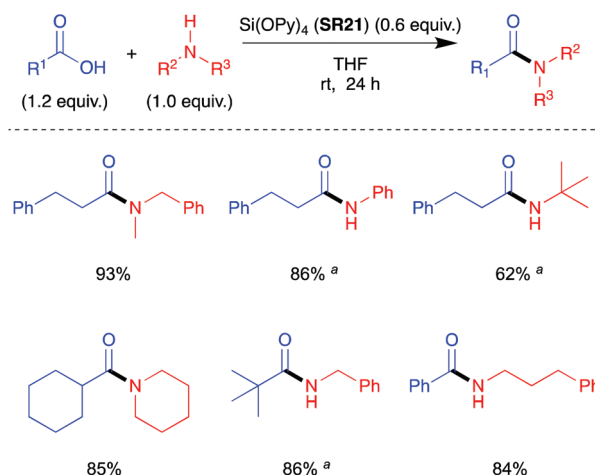
5.3. Tetramethyl orthosilicate

Mukaiyama found that simple alkoxy silanes such as tetramethyl orthosilicate (TMOS – CAUTION: fatal if inhaled, GHS: H330 – **SR23**) and tetraethyl orthosilicate (TEOS – **SR24**) gave only low conversion when used as stoichiometric coupling reagents for amidation at room temperature in THF.⁴² Sheppard also found that **SR23** gave low conversion when used as a stoichiometric coupling reagent in refluxing acetonitrile.⁴³ However, Braddock *et al.* successfully developed a TMOS based protocol in refluxing toluene to afford high yields of pure amide products from aliphatic and aromatic carboxylic acids with primary, cyclic & acyclic secondary amines and anilines as well as other challenging amidations (Scheme 13).⁴⁴ A work-up procedure based on annihilation of the silicon reagent pro-





Scheme 10 Selected amide products by direct amidation using BuSi(lm)₃ (**SR19**) and Si(2-Me-lm)₄ (**SR20**).⁴⁰ See Table 1, entries 21 and 22 for full substrate scope.

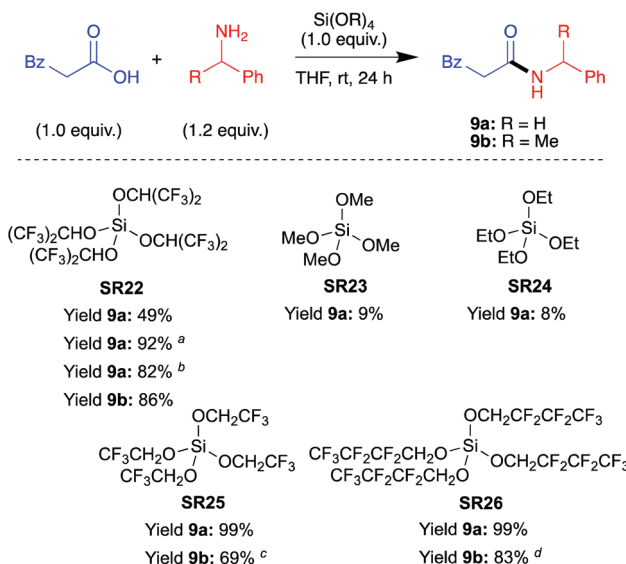


Scheme 11 Selected amide products by direct amidation using Si(OPy)₄ (**SR21**); ^a1.5 equiv. of carboxylic acid was used. See Table 1, entry 23 for full substrate scope.⁴¹

vided the pure products without the need for chromatographic purification. A one mole scale amidation was demonstrated with competitive process mass intensity, and a putative reactive silyl ester intermediated was observed *in situ* by ¹H, ¹³C and ²⁹Si NMR methods. TMOS (**SR23**) has since been demonstrated successfully for the direct amidation of carboxylic acids with pentafluorosulfanyl aniline.⁴⁵

5.4. Silicon tetraacetate

Blanchet *et al.* screened a series of commercially available silyl acetates: Me₂Si(OAc)₂ (**SR27**), MeSi(OAc)₃ (**SR28**), Si(OAc)₄ (**SR29**), to determine their ability to acetylate morpholine stoichiometrically.²⁶ The results showed that the Si(OAc)₄ provided complete conversion to 4-acetylmorpholine after only



Scheme 12 Screen of various alkoxy silanes **SR22–26** for amidation.⁴² ^aSi[OCH(CF₃)₂]₄ (0.5 equiv.) was used; ^bSi[OCH(CF₃)₂]₄ (0.25 equiv.) was used; ^c2,2,2-Trifluoroethyl ester was afforded as by-product (23% yield); ^d2,2,3,3,4,4,4-Heptafluorobutyl ester was afforded as a by-product (8% yield). See Table 1, entries 24, 27, 28, 30 and 31 for full substrate scope.

10 minutes at 0 °C in tetrahydrofuran solvent. However, after 5 h MeSi(OAc)₃ provided only 57% yield and Me₂Si(OAc)₂ gave no conversion. It was found that Si(OAc)₄ was able to acetylate a range of amines (Scheme 14). Chan had previously shown that Si(OAc)₄ (**SR29**) was competent at acylating aniline when the reaction was carried out in refluxing toluene.¹⁹

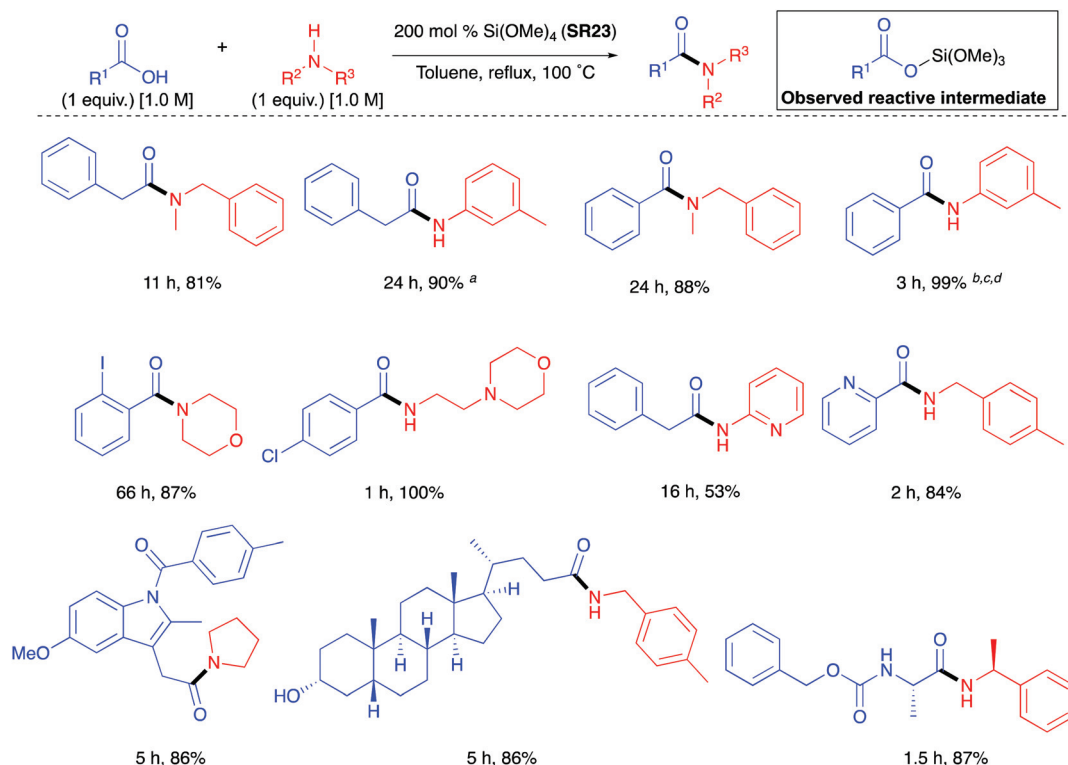
6. Heterogenous silicon reagents

In addition to the homogenous, stoichiometric silicon reagents described above there are several reports of the use of heterogenous silicas to promote effective amidation. These studies concluded that silanol groups on the surface of silicas promote the adsorption of amine and acid substrates and enable direct amidation, often with high yields.⁴⁶

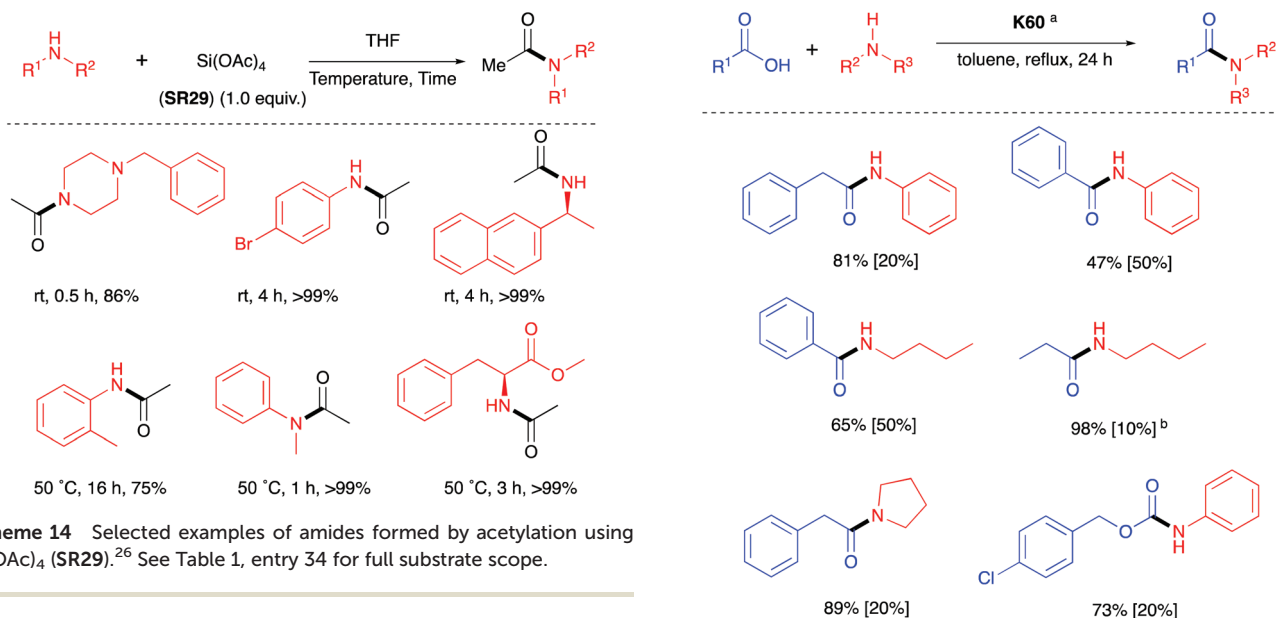
Clark *et al.* discovered that (Kieselgel 60, **K60**) could be used to promote formation of a range of alkyl and aryl amides but that pre-drying of the silica at 700 °C, was required (Scheme 15).⁴⁷ Silica gel (**K60**) has also been used by Zhang *et al.* as an effective coupling catalyst to provide a range of different amides without requiring the pre-treatment of the silica.^{47,48} Gamba-Sánchez *et al.* applied microwaves to promote amidations without the requirement for pre-treatment of the silica.⁴⁹ They found that high selectivity could be achieved with carboxylic acids providing higher yields with primary amines over cyclic secondary and aromatic amines, and also showing preference for the reaction of the amine functionality in binucleophilic substrates, such as ethanolamine.⁴⁹

Other mesoporous silicas, such as the more expensive MCM-41, have been shown by Komura *et al.* to promote amida-





Scheme 13 Selected examples of amides formed via TMOS (SR23) mediated coupling.⁴⁴ ^a[acid] = 0.5 M, [amine] = 0.5 M; ^b250 mol% TMOS, N₂, [acid] = 2.0 M, [amine] = 2.0 M; ^cWith 4 Å molecular sieves suspended in the head space; ^d2 equiv. of BzOH. See Table 1, entry 25 for full substrate scope.



Scheme 14 Selected examples of amides formed by acetylation using Si(OAc)₄ (SR29).²⁶ See Table 1, entry 34 for full substrate scope.

Scheme 15 Selected examples of amides formed via K60 mediated coupling.⁴⁷ Catalyst loading in square-brackets. ^aActivated by heating at 700 °C. ^bIsolated after 12 h.

tion of fatty acids and long chain amines.⁵⁰ The MCM-41 promoted a greater conversion of palmitic acid and *n*-hexylamine in refluxing toluene than either the activated⁴⁷ or non-activated⁴⁸ silica, with no loss in catalytic activity when recycled.⁵⁰ Komura also reported the use of mesoporous silica SBA-15 as a heterogeneous catalyst.⁵¹ Work by Fontaine *et al.* improved the catalytic activity of SBA-15 by enriching the material with Lewis

acidic metals such as Ti and Zr.⁵² When the surface silanols of the catalyst are protected with tetramethyldisilazane (TMDS) the catalytic activity drops to 9%, consistent with the silanol



groups being required for catalytic activity. SBA-15 silica with surface aminopropyl groups was also found to act as formylating agent for a series of amines and alcohols.⁵³ Another mesoporous silica, OSU-6, has been shown to catalyse amidation for a range of substrates when a neat mixture of acid and amine are mixed with the catalyst in a heated sealed pressure tube.⁵⁴

The (K60) silica^{47,48} utilized by Clark and Zhang is significantly cheaper than OSU-6, MCM-41, and SBA-15, but the more expensive silicas do not require pre-activation.

7. Conclusion

It is not surprising, that considering the worldwide demand for amides, the expectations for novel reagents for direct amidation of carboxylic acids are high. A chemist developing a novel coupling reagent with the aim of industrial implementation will need to ensure that their protocol is high yielding for a wide scope of reactants, is environmentally friendly, safe to use, and commercially available and affordable. This review shows that the silicon reagents presented above are competent at promoting amide bond formation by direct amidation of carboxylic acids with varied substrate scope. However, there is still need for improvement. A combination of broad scope, safety, environmental impact and affordability has not yet been achieved by any one of the reagents presented in this review. In terms of safety, many of the compounds (TMOS, SiCl₄ and PhSiH₃) display hazard symbols that make them uninviting to the industrial chemist. Many of the protocols presented still utilize a chromatographic purification of the amide product which does not meet the demands for an environmentally friendly amidation. The beneficial properties of several of the silicon reagents that allows for the simple conversion to insoluble siloxanes and subsequent removal by filtration, or annihilation by aqueous work-up, should be pursued and exploited with the aim of reducing process mass intensities. Notably, the majority of reagents presented are commercially available making them attractive to the synthetic community. However, the search remains for a silicon-based reagent that meets all these highly demanding criteria.⁵⁵ Moreover, the advent of a silicon-based catalyst for direct amidation would be a further advance and is overdue.

Conflicts of interest

There are no conflicts to declare.

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